



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

*Amolt B*  
11.7.02  
*C. Moore*

Application Serial No. ....09/881,408  
Filing Date ..... June 13, 2001  
Inventor..... Kie Y. Ahn, et al  
Assignee..... Micron Technology, Inc.  
Group Art Unit.....2814  
Examiner ..... T. Le  
Attorney's Docket No. ....MI22-1534  
Title: A Dielectric Layer Forming Method and Devices Formed Therewith

**RESPONSE TO JULY 26, 2002 OFFICE ACTION**

To: Attn: Art Unit 2814  
Assistant Commissioner for Patents  
Washington, D.C. 20231

From: James E. Lake (Tel. 509-624-4276; Fax 509-838-3424)  
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Adjustment date: 03/19/2003 EERUBAYI  
11/12/2002 CWILLS 00000001 230925 09881408  
01 FC:1251 110.00 CR

11/13/2002 CWILLS 00000004 230925 09881408  
01 FC:1251 110.00 CH

**AMENDMENTS**

**In the Claims**

Please cancel claim 53, add new claims 56-59, and replace claims 1-4, 6-8, 10, 20-22, 52, 54, and 55 with the following clean version of the amended claims in accordance with 37 C.F.R. § 1.121(c)(1)(i). Cancel all previous versions of any amended claim.

A marked up version showing amendments to any claims being changed is provided in one or more accompanying pages separate from this amendment in accordance with 37 C.F.R. § 1.121(c)(1)(ii). Any claim not accompanied by a marked up version has not been changed relative to the immediate prior version, except that marked up versions are not being supplied for any added claim or canceled claim.

11/08/2002 CWILLS 00000002 230925 09881408  
01 FC:1201 168.00 CH

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